

**CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)**  
Applicant(s): TANABE et al.

Docket No.

NEC WNZ-2212

Serial No.  
09/612,551Filing Date  
July 7, 2000Examiner  
Geoffrey S. EvansGroup Art Unit  
1725

Invention: SEMICONDUCTOR THIN FILM FORMING SYSTEM

I hereby certify that this Amendment F under Rule 116 and Petition for One Month Extension of Time  
(Identify type of correspondence)  
is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9311)  
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Shauna Bronson

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## Transmitted herewith:

1. Amendment F under Rule 116 (3 pgs);
2. Petition for One Month Extension of Time (1 pg); and
3. form PTO-2038 for Extension fees (1 pg).